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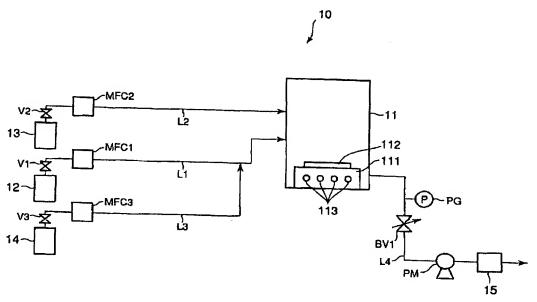
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(54) Title: METHODS FOR PRODUCING SILICON NITRIDE FILMS BY VAPOR-PHASE GROWTH



(57) Abstract: To provide a method that is not accompanied by the production of ammonium chloride, avoids significant admixture of carbonaceous contaminants in the film products, and can produce silicon nitride films with improved film properties even at relatively low temperatures. Silicon nitride films are formed on substrates by feeding a hydrazine gas and at least 1 precursor gas selected from the group consisting of trisilylamine gas and a silylhydrazine gas into a reaction chamber (11) that holds at least 1 substrate (112) and inducing the vapor-phase reaction of the two gases. Silylhydrazine gas can also produce silicon nitride films by itself by thermal decomposition.

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INTERNATIONAL SEARCH REPORT

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Minimum documentation searched (classification system followed by classification symbols) IPC $\frac{7}{230}$

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Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

EPO-Internal, WPI Data, PAJ, INSPEC, COMPENDEX

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Y	vol. 429, no. 1-2, 1 April 2003 (2003-04-01), pages 144-151, XP004421425 ISSN: 0040-6090 page 144 - page 145	9
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Further documents are listed in the continuation of box C.	Patent family members are listed in annex.
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